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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q76117

Hiroyuki KIYOKU, et al.

Appln. No.: 10/600,833

Group Art Unit: 2826

Confirmation No.: 6364

Examiner: Thomas L. DICKEY

Filed: June 23, 2003

For: NITRIDE SEMICONDUCTOR GROWTH METHOD, NITRIDE SEMICONDUCTOR
SUBSTRATE, AND NITRIDE SEMICONDUCTOR DEVICE

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

A petition and fee for 2 months extension of time to extend the time period for
response to the Office Action dated June 16, 2004 to November 16, 2004, are
submitted herewith.

Please amend the above-identified application as follows on the accompanying
pages.

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